

Development of Superconducting Accelerator with ERL for EUV-FEL

KEK, High Energy Accelerator Research Organization
Japan

SRF team / ERL-EUV feasibility study Group
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ERL-EUV feasibility study Group

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(JAEA) R. Hajima, N. Nishimori

**The feasibility study has been done under collaboration with
a Japanese company.**

In this Workshop,

R. Hajima (JAEA);

“Design of high power free electron Lasers for EUV lithography applications”



Outline

- 1. Introduction – SRF activities at KEK**
- 2. ERL for EUV-FEL**
- 3. Toward Realizing SRF Accelerator for EUV**
- 4. Construction Plan of Prototype ERL/EUV-FEL**
- 5. Summary**



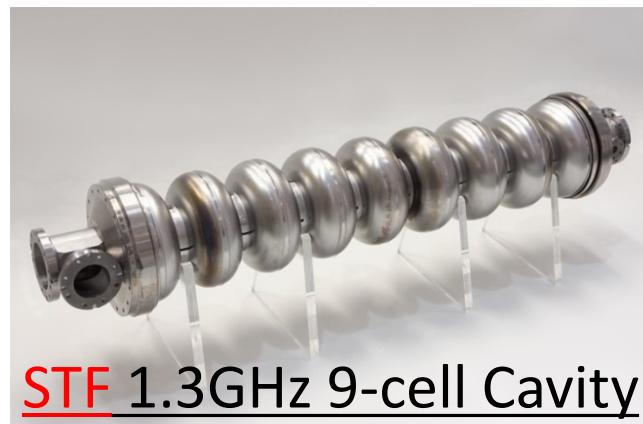
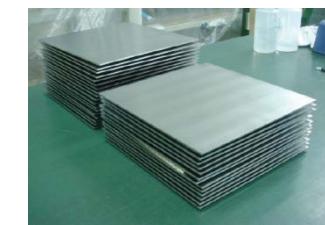
1. Introduction – SRF activities at KEK



Tristan 508MHz 5-cell Cavity



KEKB 508MHz
1-cell Cavity

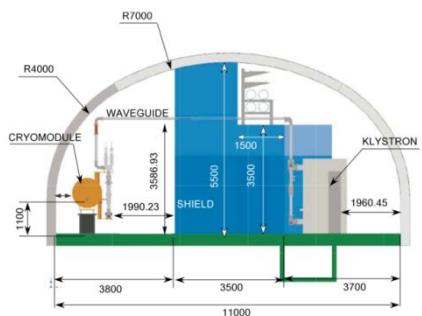
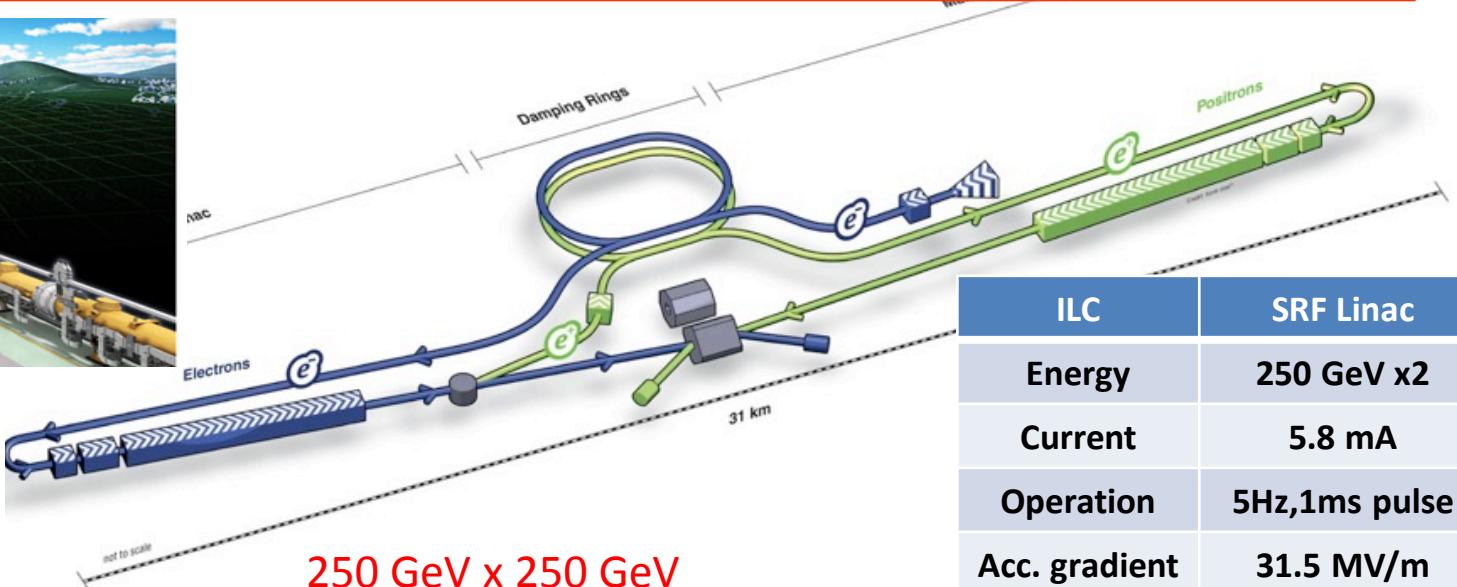
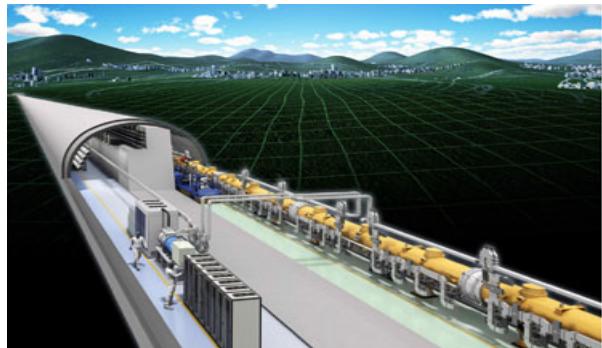
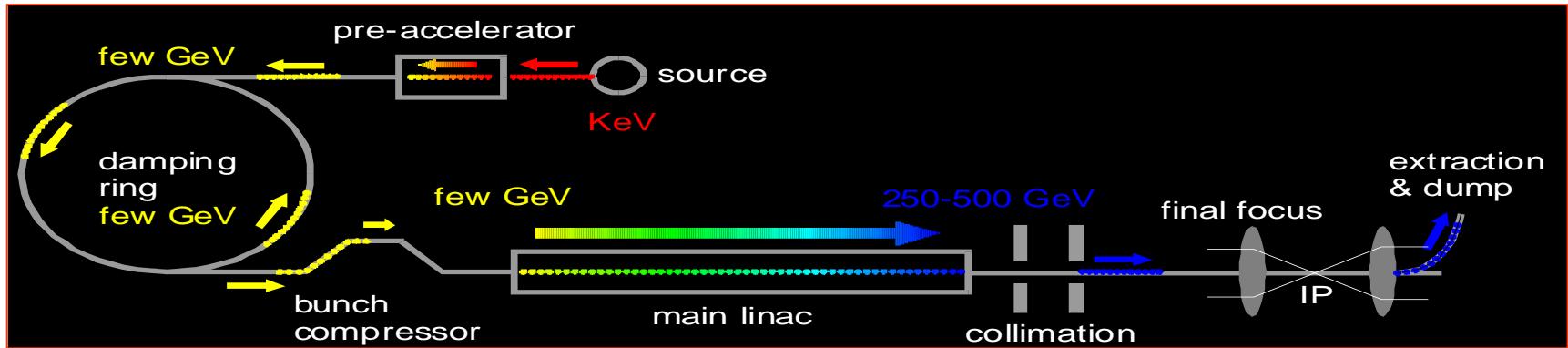


cERL Injector
1.3GHz 2-cell Cavity

cERL ML
1.3GHz 9-cell Cavity

STF 1.3GHz 9-cell Cavity

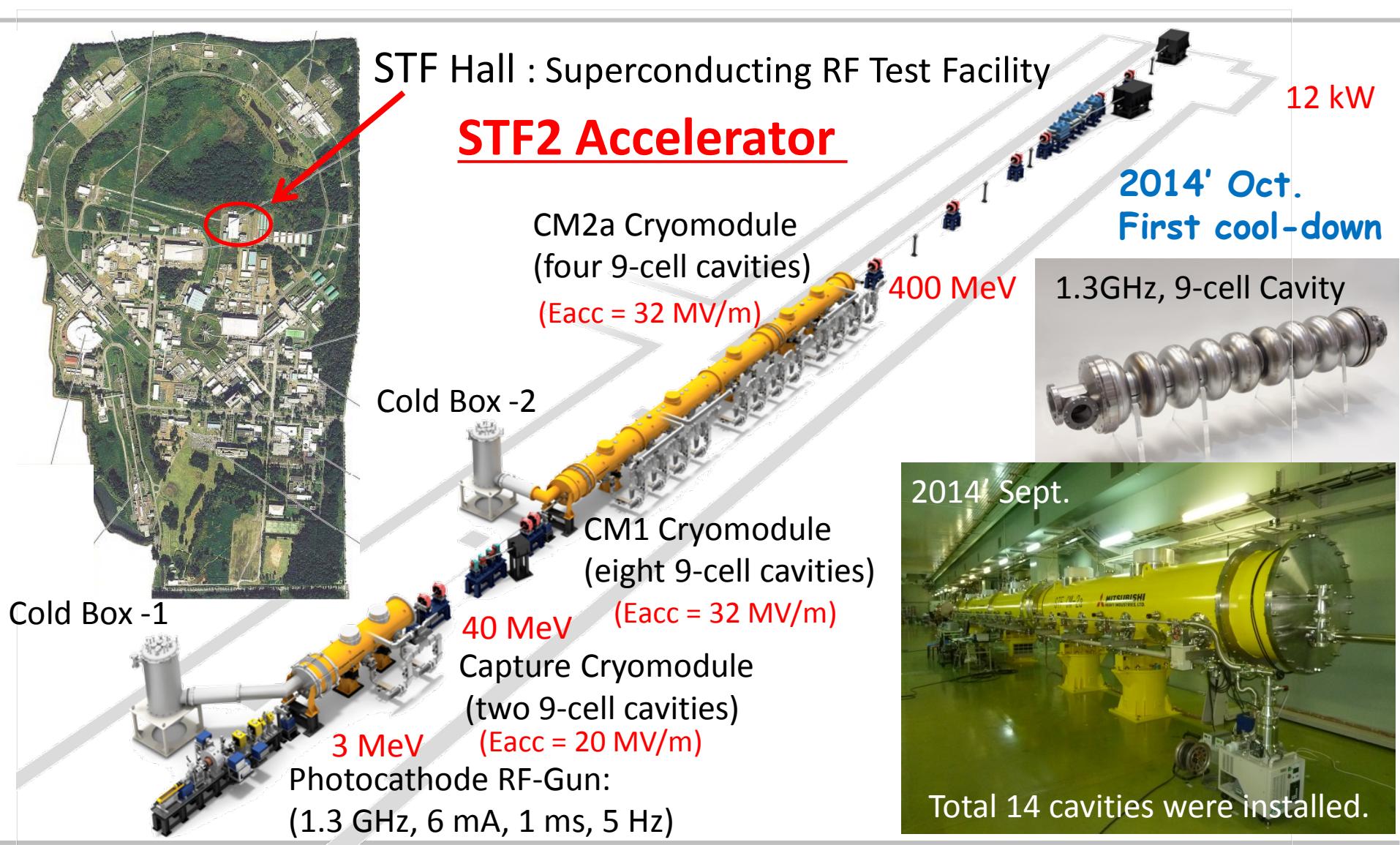
ILC (International Linear Collider)



Total tunnel length : 31 km

ILC	SRF Linac
Energy	250 GeV x2
Current	5.8 mA
Operation	5Hz, 1ms pulse
Acc. gradient	31.5 MV/m
No. of cavity	16,000
No. module	1,800 (9 cav.)

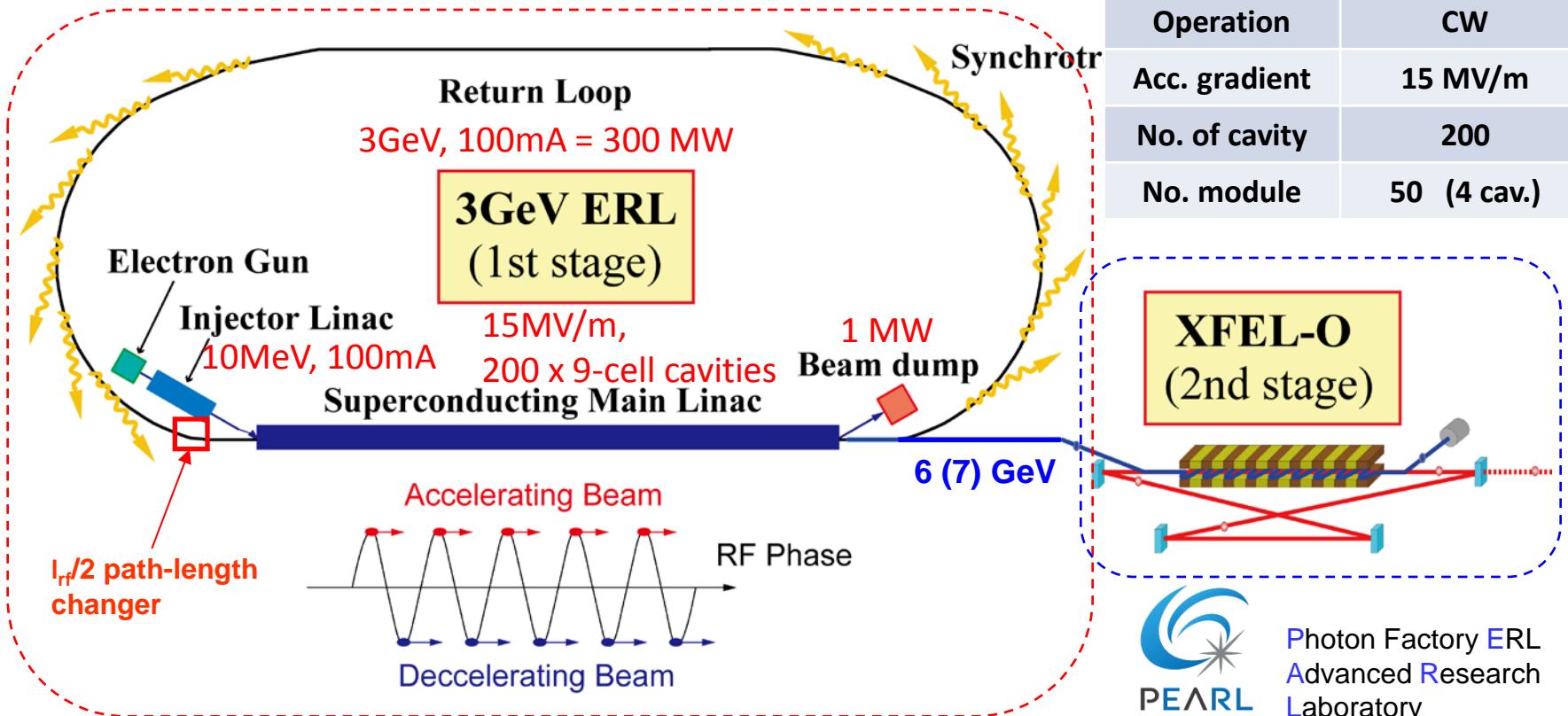
STF2 for future ILC



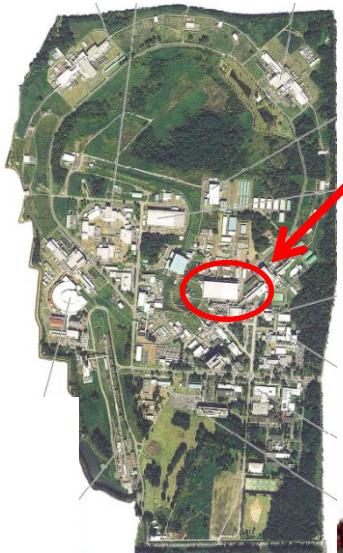
ERL (Energy Recovery Linac)

ERL-based Light Source Project at KEK (2 Stages)

- ① 3-GeV ERL as X-ray and VUV SR source
- ② 6-7 GeV XFEL Oscillator

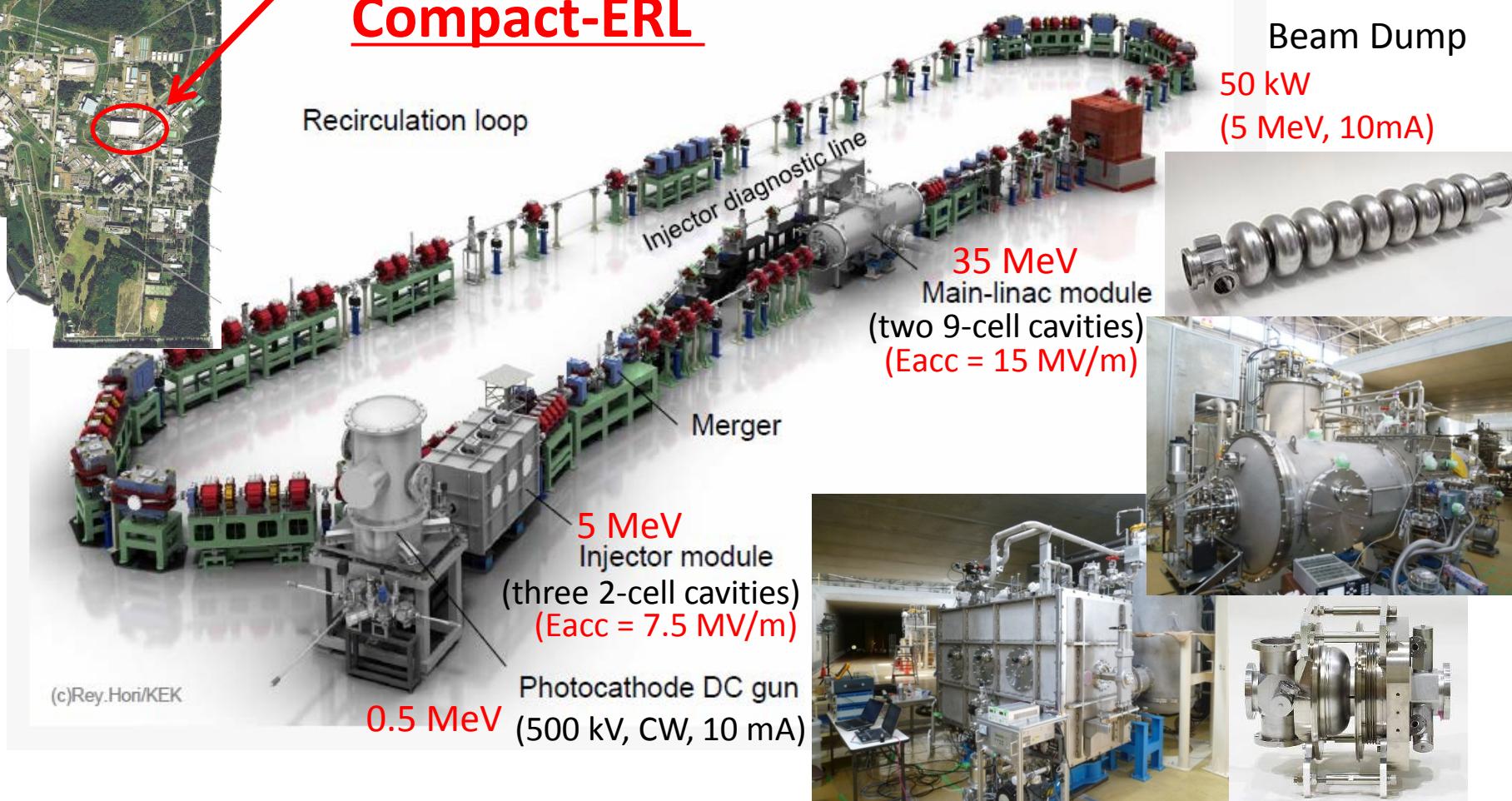


cERL for future 3GeV-ERL



ERL R&D Hall : Energy Recovery Linac

Compact-ERL

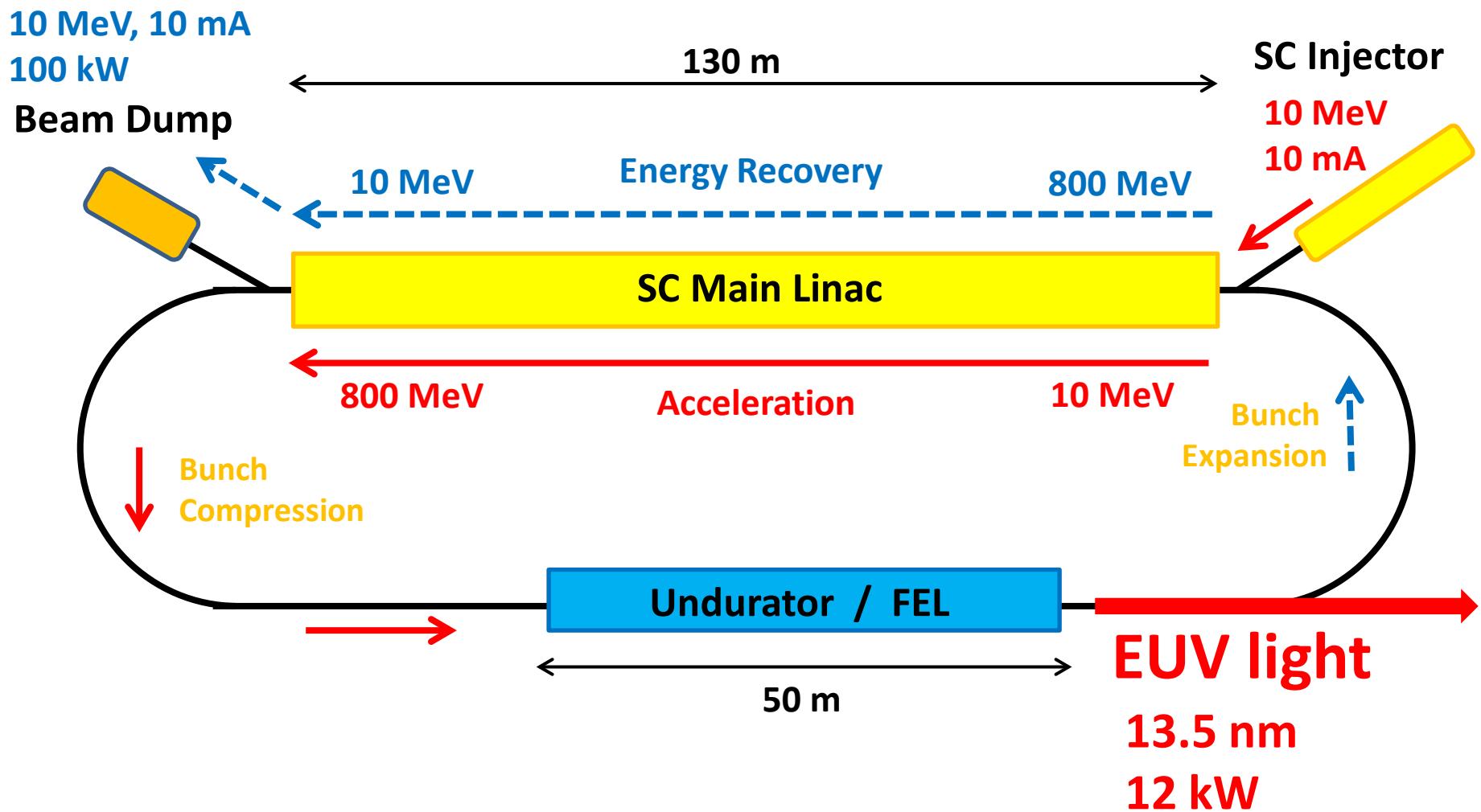


2014' March,
Beam operation

Beam Dump

50 kW
(5 MeV, 10mA)

2. ERL for EUV-FEL



ERL Parameters for EUV/FEL

ERL	EUV/FEL
Injection Energy	10 MeV
Beam Energy	800 MeV
Bunch Charge	100 pC
Repetition Rate	81.25 MHz
ave. Current	8.125 mA
Energy Spread	0.1% rms
Normalised Emittance	0.8 mm.mrad
Undulator Gap	10 mm
EUV wavelength	13.5 nm
EUV output power	12 kW



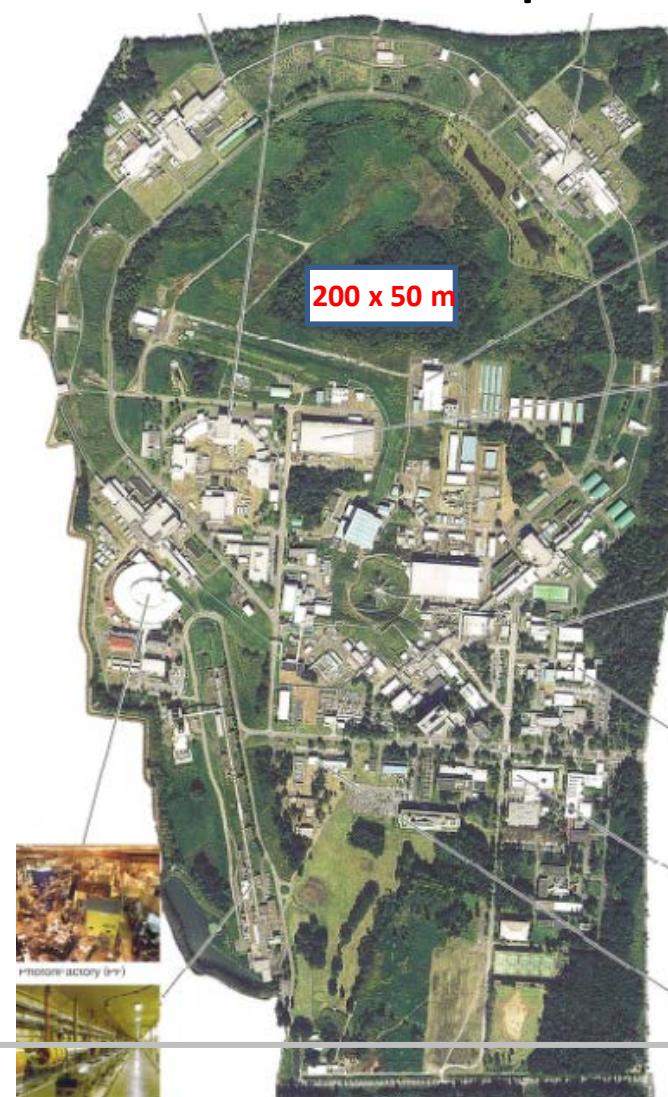
2014 International Workshop
on EUV and Soft X-Ray Sources
Dublin, Ireland
November 3-6, 2014

Eiji Kako (KEK, Japan) Nov. 04. 2014'

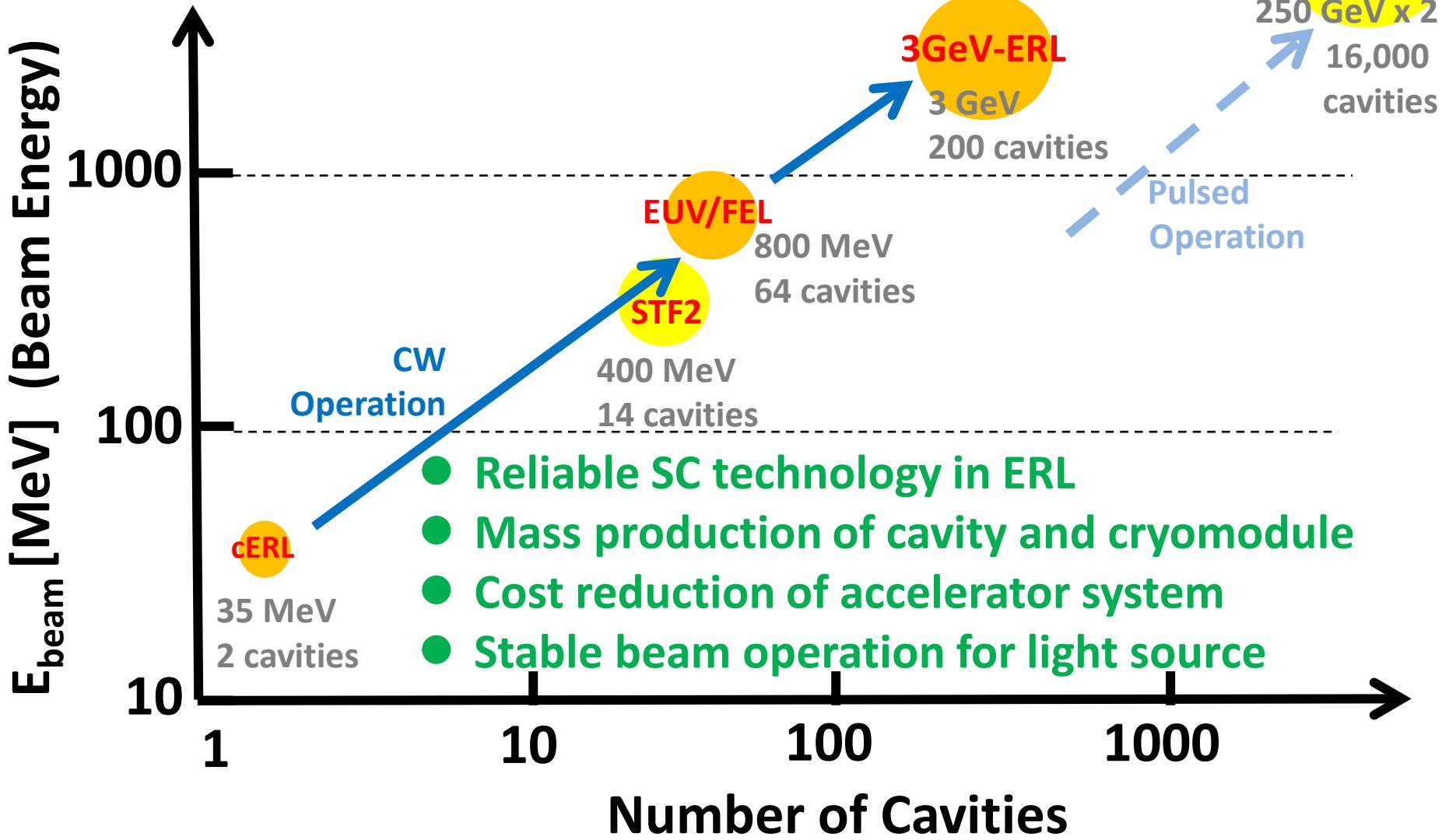
Accelerator Parameters for ERL

ERL	Main LINAC
Beam Energy	800 MeV
ave. Current	8.125 mA
Accelerating Gradient	12.5 MV/m
No. of Cavity	64
No. of Cryomodule	16 (4 cav./module)
Linac Length	130 m (Pac. Fac. 50%)
RF Power per cavity	2 kW ($Q_{in} = 2 \times 10^7$)
Beam Dump Power	81 kW
Cavity Loss at 2K	1.0 kW ($Q_0 = 1 \times 10^{10}$)
Cryogenic Plant	7.0 kW (at 4K)

KEK Tsukuba Campus



Strategy for future project at KEK

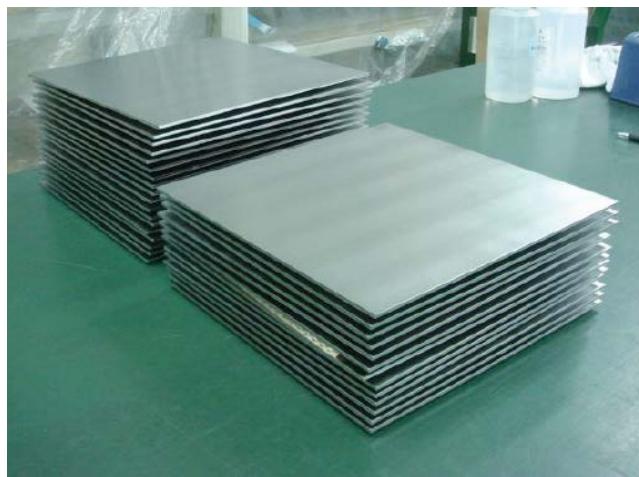


R&D issues for ERL/EUV Cryomodule

- **Optimum design** of cell-shape, He-jacket and cryomodule structure fitted for EUV light source are absolutely necessary.
- Construction and cool-down tests of **a proto-type cryomodule** including four 9-cell cavities are the most important R&D task.
- **HOM absorbers** are a key R&D components.
- Surface preparation and performance tests at low temperature of the cavities are available at infrastructures in STF.
- High power tests of the assembled cryomodules are carried out after on-site installation in an accelerator beam line.
- Selection of a **construction site** of ERL/EUV accelerator, ordering of a **cryogenic system** and purchase of all **Nb sheets** should be decided in the starting stage of the project to keep the schedule.



3. Toward Realizing SRF Accelerator for EUV

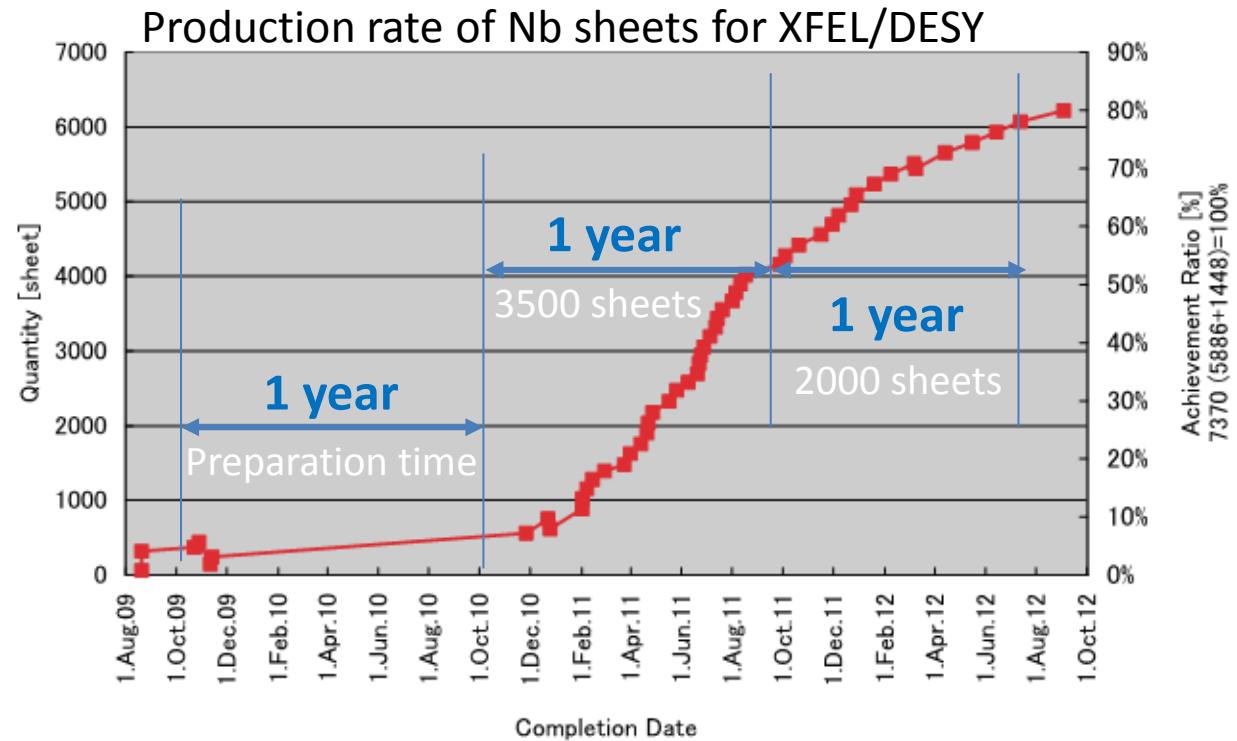


H. Umezawa,
TTC-meeting at JLab, USA
(Nov., 2012)

18 sheets / 9-cell cavity

**18 sheets x 64 cavities x 1.10
= 1300 sheets (Nb : 1.5 ton)**

High Purity Niobium Material (by Tokyo-Denkai, Japan)



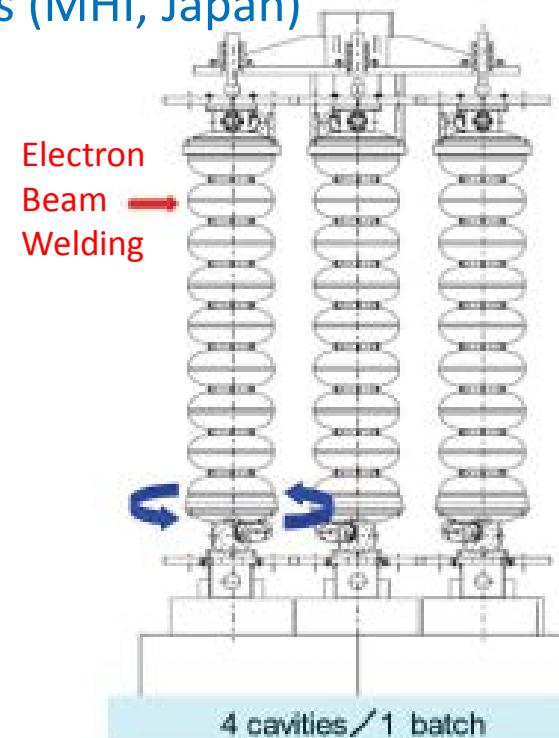
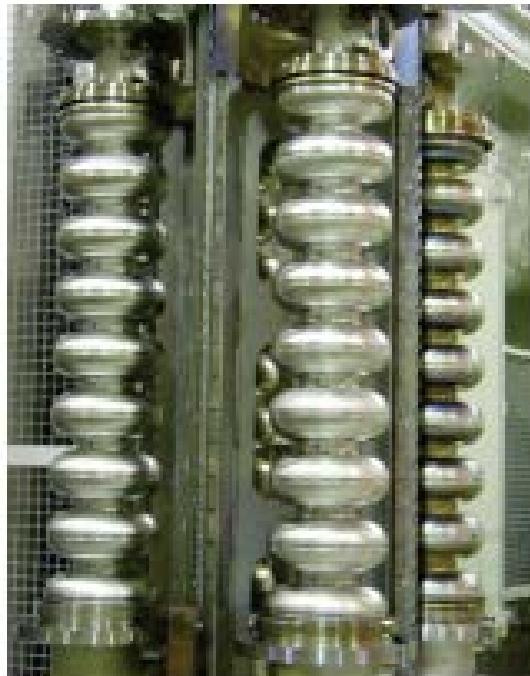
1300 sheets → about one year



Fabrication of 9-cell Nb cavities (by MHI)



Mitsubishi Heavy Industries (MHI, Japan)



T. Yanagisawa et al. SRF2013, Paris, France (2013), MOP055

**4 cavities / 2 weeks
8 cavities / month
80 cavities / year**

**64 9-cell cavities
→ about one year**

Surface preparation & Cavity tests (at STF/KEK)

Vertical Test Cycle
at STF/KEK



EP (Electro-Polishing)
device x 2



Assembly in CR,
Baking stand x 2



Hanging stand x 4



VT (Vertical Test)
cryostat x 2

2 V.T. / week
80 V.T. / year

64 cavities
→

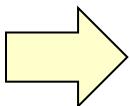
about one year



Cavity string assembly
in clean room 16

Cryomodule Assembly (at STF/KEK)

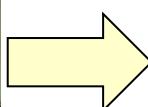
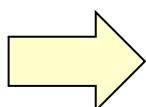
Four 9-cell cavities / Cryomodule



Cavity string assembly
1+1 week

1 CM / 6 weeks
8 CM / year
x 2 lines by overlap
= 16 CM / year

16 Cryomodules
including 64 cavities
→ about one year

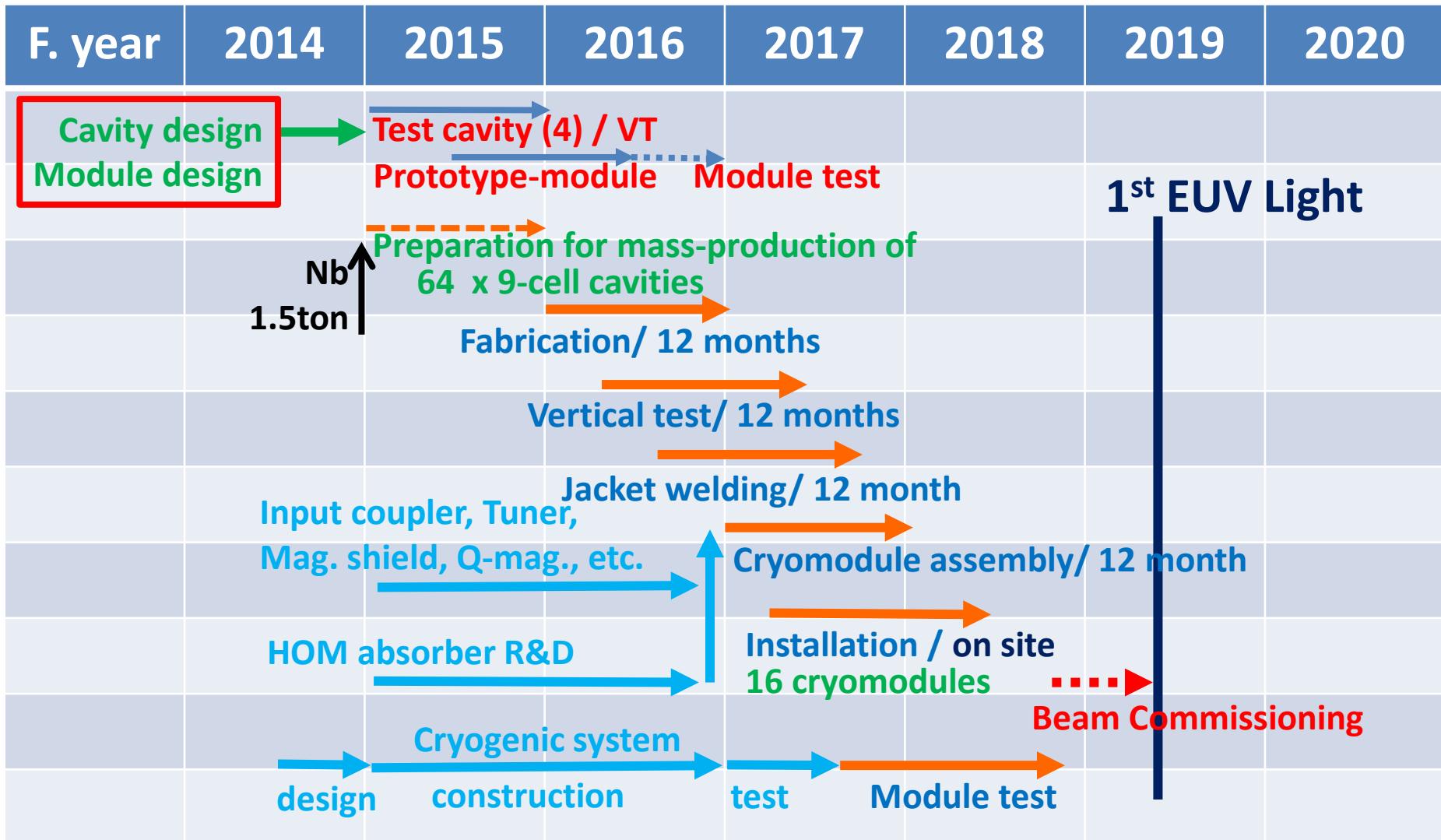


Insertion into vacuum vessel
1 week



Installation of input couplers
1 week

4. Construction plan of Prototype ERL for EUV/FEL



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5. Summary

Message to EUV-Lithography Community

- EUV light source by using ERL is technically available in power levels around 10 kW, presently.
- Infrastructures for construction of prototype ERL for EUV/FEL is ready at KEK, and the realistic construction schedule of the prototype ERL for EUV/FEL was shown.
- First EUV light could be possible in 2019,
if the R&D is started just now.



Thank you for your attentions !

